

## Supporting Information

Tailoring optoelectronic properties and dielectric profile of few-layers S-doped

MoO<sub>3</sub> and O-doped MoS<sub>2</sub> nanosheets: a first-principles study

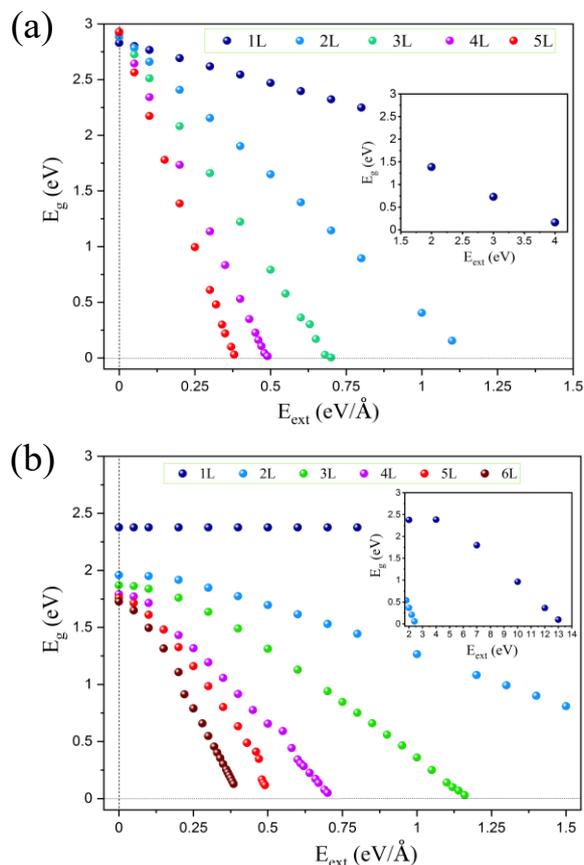
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## S1. Optoelectronic properties of non-doped 4L MoO<sub>3</sub> and O-doped 6L MoS<sub>2</sub>

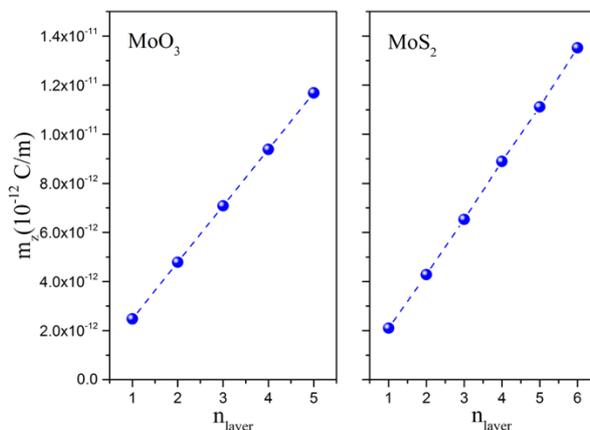


**Figure S1.** Calculated electronic band gap as a function of external electric field ( $E_{ext}$ ) along out-of-plane direction for 1L-5L MoO<sub>3</sub> (a) and 1L-6L MoS<sub>2</sub> (b) within HSE06. Insets show the electronic band gap of FL MoO<sub>3</sub> and MoS<sub>2</sub> as a function of strong electric field ( $E_{ext} > 1.5$  eV/Å).

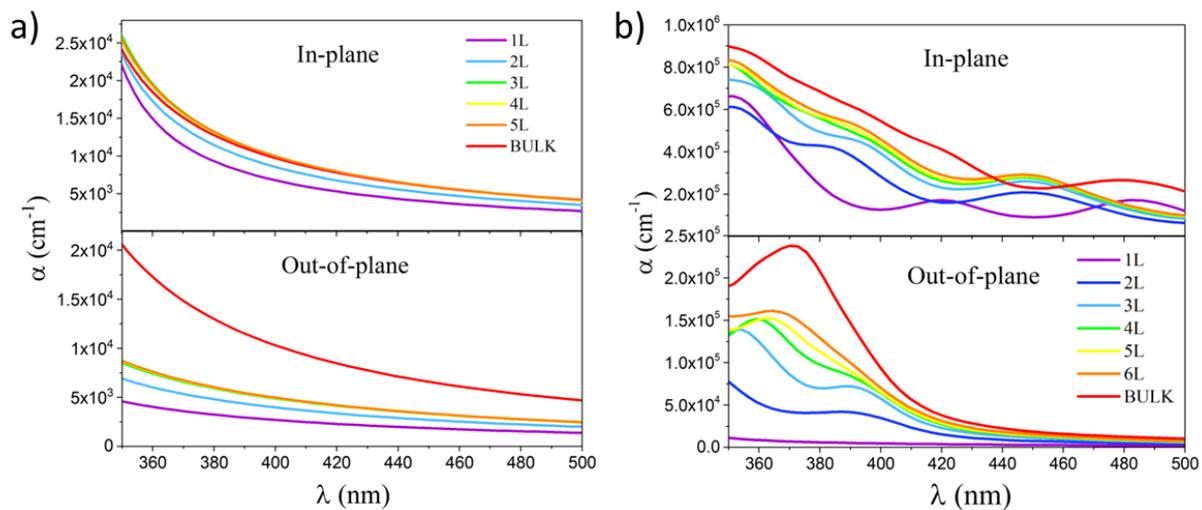
The electronic band gap of MoO<sub>3</sub> and MoS<sub>2</sub> multilayers shows a monotonous decrease with increasing external electric field. Whereas the band gap of single-layer structures slightly decreases for electric field from 0 eV/Å to 1 eV/Å, it reduces drastically by applying stronger electric fields  $E_{ext} > 2$  eV/Å for SL MoO<sub>3</sub> and  $E_{ext} > 7$  eV/Å for SL MoS<sub>2</sub>.

As explained in Refs.<sup>1,2</sup>, the initial step of the microscopic dielectric profile calculation is a study of the variation of the total induced dipole ( $m_z$ ) of multilayer MoO<sub>3</sub> and MoS<sub>2</sub> systems as a function of the number of layers. According to Refs.<sup>1,2</sup>, it is expected that only for small external electric field, the

induced dipole have a linear variation as a function of  $E_{\text{ext}}$ . The slope of the inverse dipole variation as a function of  $1/L$  ( $L$  is array period between two layered slabs), is equal to  $1/(\epsilon_0 E_{\text{ext}})$ .



**Figure S2.** Variation of the induced dipole  $m_z$  for pristine MoO<sub>3</sub> and MoS<sub>2</sub> layered structures with increasing number of layers. The external electric field is  $E_{\text{ext}} = 0.025 \text{ eV/\AA}$ .



**Figure S3.** Computed absorption coefficients ( $\alpha$ , in  $\text{cm}^{-1}$ ) along in-plane and out-of-plane for a) 1L-5L and bulk MoO<sub>3</sub> and b) 1L-6L and bulk MoS<sub>2</sub> (right panel) within HSE06 approach.

## S2. S-doped 4L MoO<sub>3</sub> and O-doped 6L MoS<sub>2</sub>

### S2.1. Structural properties

S concentration (%)	System	corresponding cell	corresponding figure	<i>k</i> -point mesh	<i>a</i> (Å)	<i>b</i> (Å)	<i>T</i> (Å)	<i>E<sub>b</sub></i> (eV)	<i>E<sub>g</sub></i> (eV)	$\epsilon_{eff}$
<b>0.0</b>	MoO <sub>3</sub>	unit cell	Fig. S5 (a)	12×12×1	3.712	3.934	27.315	-8.00	2.92	3.60
<b>4.16 (bulk)</b>	MoS <sub>0.12</sub> O <sub>2.88</sub>	unit cell	Fig. S5 (b)	12×12×1	3.714	3.928	28.675	-7.72	1.48	4.08
<b>4.16 (edge)</b>	MoS <sub>0.12</sub> O <sub>2.88</sub>	unit cell	Fig. S5 (c)	12×12×1	3.714	3.930	27.737	-7.75	2.18	3.96
<b>8.33 (bulk-configure-1)</b>	MoS <sub>0.25</sub> O <sub>2.75</sub>	unit cell	Fig. S5 (d)	12×12×1	3.715	3.933	29.342	-7.46	1.86	4.99
<b>8.33 (bulk-configure-2)</b>	MoS <sub>0.25</sub> O <sub>2.75</sub>	unit cell	Fig. S5 (e)	12×12×1	3.716	3.924	30.00	-7.43	1.46	5.14
<b>8.33 (bulk-configure-3)</b>	MoS <sub>0.25</sub> O <sub>2.75</sub>	unit cell	Fig. S5 (f)	12×12×1	3.716	3.925	29.92	-7.44	1.46	5.15
<b>8.33 (edge)</b>	MoS <sub>0.25</sub> O <sub>2.75</sub>	unit cell	Fig. S5 (g)	12×12×1	3.716	3.925	28.166	-7.49	2.16	4.15
<b>16.66 (bulk)</b>	MoS <sub>0.5</sub> O <sub>2.5</sub>	unit cell	Fig. S5 (h)	12×12×1	3.713	3.934	29.52	-6.88	0.00	-----
<b>16.66 (edge-pre-edge-configure-1)</b>	MoS <sub>0.5</sub> O <sub>2.5</sub>	unit cell	Fig. S5 (i)	12×12×1	3.72	3.898	31.10	-6.92	0.65	5.65
<b>16.66 (bulk-edge-configure-2)</b>	MoS <sub>0.5</sub> O <sub>2.5</sub>	unit cell	Fig. S5 (j)	12×12×1	3.719	3.921	30.261	-6.94	1.85	5.32
<b>25</b>	MoS <sub>0.75</sub> O <sub>2.25</sub>	unit cell	Fig. S5 (k)	12×12×1	3.723	3.916	32.821	-6.38	1.44	5.93
<b>33</b>	MoSO <sub>2</sub>	unit cell	Fig. S5 (l)	12×12×1	3.724	3.922	34.306	-5.86	1.86	7.51

Table S1. Different models, corresponding figures, *k*-point mesh, calculated optimized lattice parameters (*a* and *b*), calculated the layer thickness (*T*), binding energy (*E<sub>b</sub>*) per MoO<sub>3</sub>, the electronic band gap (*E<sub>g</sub>*) and effective high frequency dielectric constant ( $\epsilon_{eff}$ ) along out-of-plane direction for the S-substituted 4L MoO<sub>3</sub> for different concentrations.

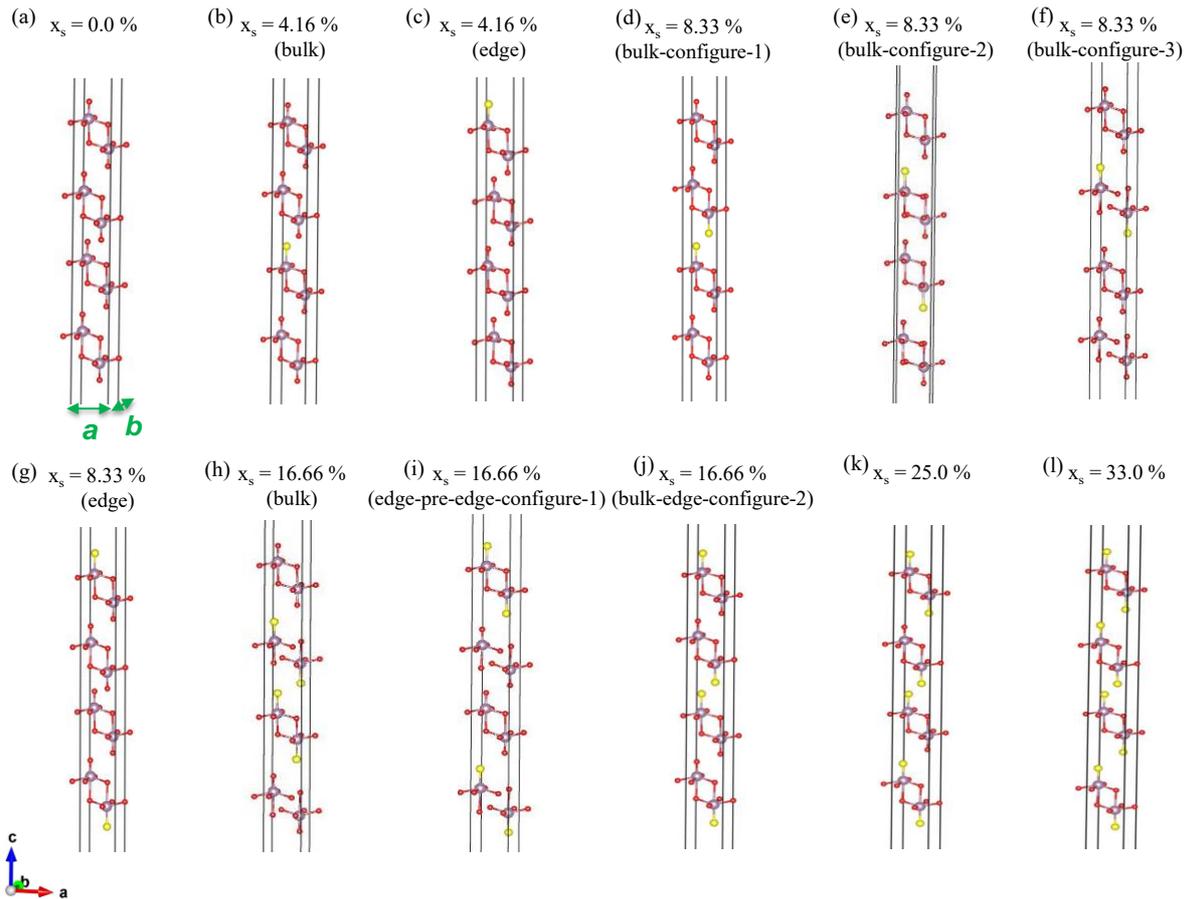
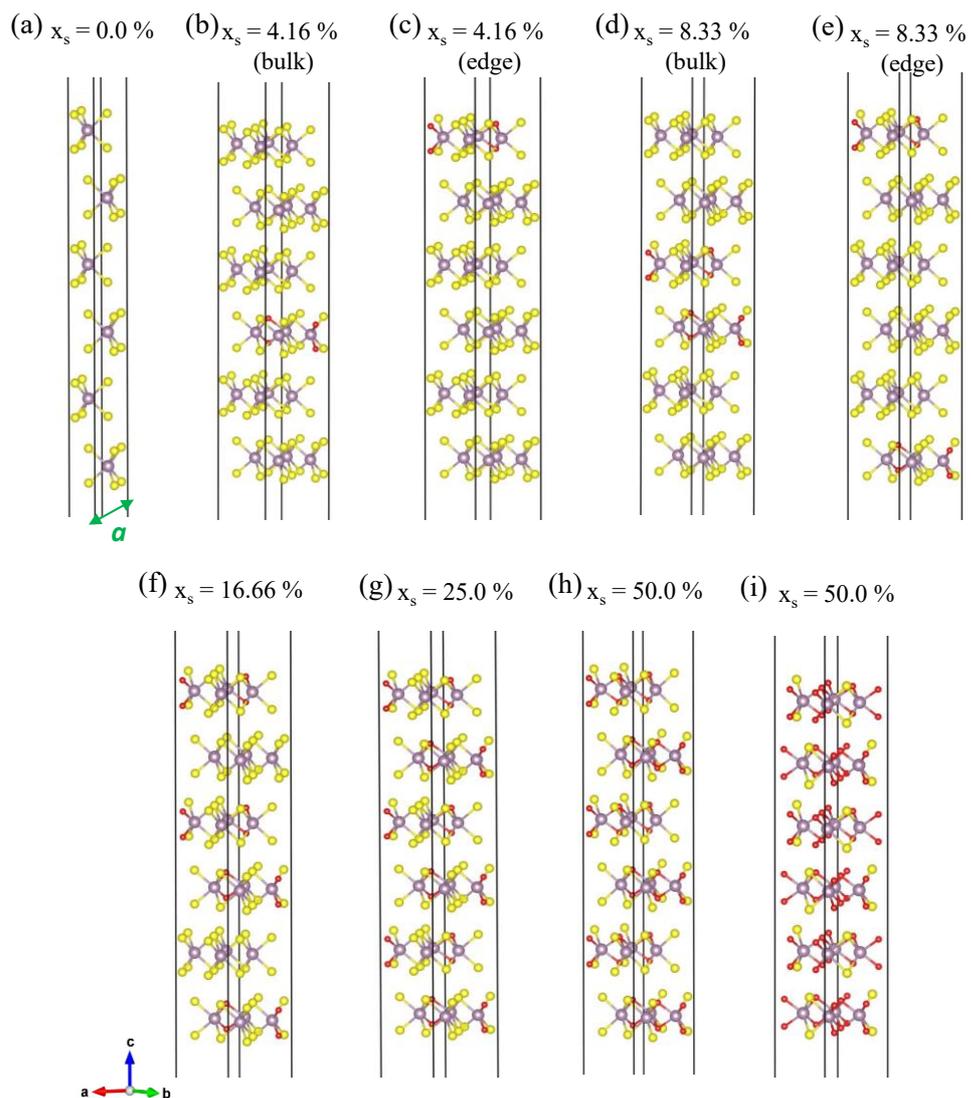


Figure S4. Optimized structures of S-doped 4L MoO<sub>3</sub> for different concentrations. The purple, red and yellow balls in the geometrical models represent the Mo, O and S atoms, respectively. The lattice parameters of pristine structure are also shown with green arrows.

O concentration (%)	System	corresponding cell	corresponding figure	<i>k</i> -point mesh	<i>a</i> (Å)	<i>T</i> (Å)	<i>E<sub>b</sub></i> (eV)	<i>E<sub>g</sub></i> (eV)	<i>ε<sub>eff</sub></i>
0.0	MoS <sub>2</sub>	unit cell	Fig. S6 (a)	12×12×1	3.156	33.860	-2.250	1.73	6.26
4.16 (bulk)	MoO <sub>0.08</sub> S <sub>1.92</sub>	(2 × 2)	Fig. S6 (b)	6×6×1	3.141	33.837	-2.349	1.21	6.14
4.16 (edge)	MoO <sub>0.08</sub> S <sub>1.92</sub>	(2 × 2)	Fig. S6 (c)	6×6×1	3.141	33.855	-2.353	1.27	6.22
8.33 (bulk)	MoO <sub>0.17</sub> S <sub>1.83</sub>	(2 × 2)	Fig. S6 (d)	6×6×1	3.125	33.810	-2.453	1.27	6.00
8.33 (edge)	MoO <sub>0.17</sub> S <sub>1.83</sub>	(2 × 2)	Fig. S6 (e)	6×6×1	3.125	33.889	-2.458	1.38	6.13
16.66	MoO <sub>0.33</sub> S <sub>1.67</sub>	(2 × 2)	Fig. S6 (f)	6×6×1	3.095	33.879	-2.681	1.48	5.77
25	MoO <sub>0.5</sub> S <sub>1.5</sub>	(2 × 2)	Fig. S6 (g)	6×6×1	3.065	33.845	-2.923	1.62	5.35
50	MoOS	(2 × 2)	Fig. S6 (h)	6×6×1	2.980	33.835	-3.661	1.75	4.44
75	MoO <sub>1.5</sub> S <sub>0.5</sub>	(2 × 2)	Fig. S6 (i)	6×6×1	2.890	31.290	-4.482	1.54	3.78

Table S2. Different models, corresponding figures, *k*-point mesh, calculated optimized lattice parameter (*a*), calculated the layer thickness (*T*), binding energy (*E<sub>b</sub>*) per MoS<sub>2</sub>, the electronic band gap (*E<sub>g</sub>*) and effective high frequency dielectric constant (*ε<sub>eff</sub>*) along out-of-plane direction for the O-substituted 6L MoS<sub>2</sub> for different concentrations.



**Figure S5. Optimized structures of O-doped 6L MoO<sub>3</sub> for different concentrations. The purple, red and yellow balls in the geometrical models represent the Mo, O and S atoms, respectively. The lattice parameters of pristine structure are also shown with green arrows.**

## S2.2 Energetics and thermodynamic analysis

To evaluate the energetics of S-doped 4L MoO<sub>3</sub> structures, the binding energies ( $E_b$ ) normalized per MoO<sub>3</sub> were computed as

$$E_b = \frac{E_{tot} - (n_{Mo}E_{Mo} + (\frac{1}{2})n_OE_{O_2} + n_S E_{S\alpha})}{N/4} \quad (1)$$

and the binding energies of O-doped 6L MoS<sub>2</sub> structures normalized per MoS<sub>2</sub> were computed as

$$E_b = \frac{E_{tot} - (n_{Mo}E_{Mo} + n_S E_{S\alpha} + (\frac{1}{2})n_OE_{O_2})}{N/3} \quad (2)$$

where  $E_{tot}$  is the total energy per cell,  $E_i$  is the energy of the  $i$ -th individual elements in their respective ground states,  $n_i$  is the number of species  $i$  in the structure and  $N/4$  and  $N/3$  are the number of MoO<sub>3</sub> and MoS<sub>2</sub> per unit cell.

However, the binding energy cannot discriminate the relative stability of structures with various chemical compositions. Hence, to determine the thermodynamic stability of 4L MoO<sub>3-x</sub>S<sub>x</sub> and 6L MoS<sub>2-x</sub>O<sub>x</sub> compositions as a function of the number of S- or O-atoms exchanged in the 4L MoO<sub>3</sub> and 6L MoS<sub>2</sub> layered structures respectively, we calculate the Grand potential,  $\Omega$ , assuming that the reservoir surrounding the solids is constituted from ideal gas phase mixtures of H<sub>2</sub>S/H<sub>2</sub>O (commonly used experimentally as sulfiding and oxidizing agents):



$$\Omega_{MoO_{3-x}S_x} = E_b(4L MoO_{3-x}S_x) - E_b(4L MoO_3) + xG_{f,T_0}^0(H_2O) - xG_{f,T_0}^0(H_2S) - xRT_0 \ln \left[ \frac{p(H_2S)}{p(H_2O)} \right] \quad (5)$$

$$\Omega_{MoS_{2-x}O_x} = E_b(6L MoS_{2-x}O_x) - E_b(6L MoS_2) + xG_{f,T_0}^0(H_2S) - xG_{f,T_0}^0(H_2O) - xRT_0 \ln \left[ \frac{p(H_2O)}{p(H_2S)} \right] \quad (6)$$

where  $E_b$  stands for the 0 K, binding energies of the different solids involved (neglecting vibrational and entropic contributions, see also supporting information),  $G_{f,T_0}^0$  stands for the Gibbs free energies of formation of H<sub>2</sub>S and H<sub>2</sub>O molecules (including thermal and entropic effects evaluated from NIST data base at T<sub>0</sub>=298 K). So, for each value of  $x$ , we will plot the evolution of  $\Omega_x$  as a function of the variable  $\pm RT_0 \ln \left[ \frac{p(H_2O)}{p(H_2S)} \right]$  fixing the partial pressures of H<sub>2</sub>S/H<sub>2</sub>O in the reservoir assumed at T<sub>0</sub>=298 K. It is worth to note that increasing T slightly diminishes (increases, respectively) the free enthalpy of oxidation (sulfidation, respectively) reaction. However, the main trends reported at ambient T are only very weakly affected.

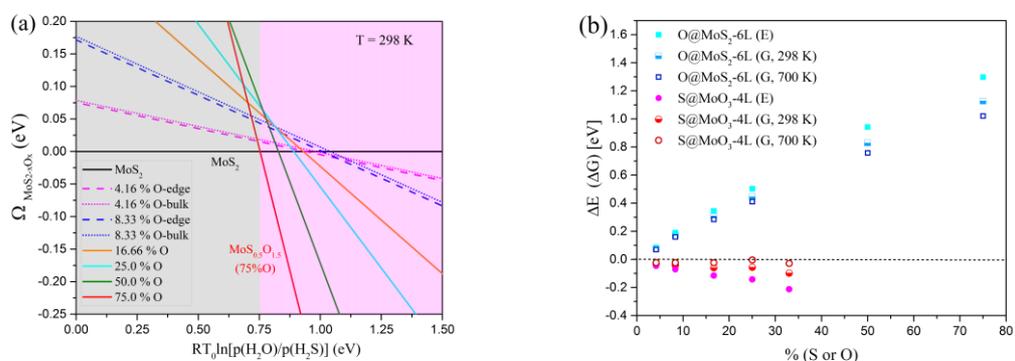
For the more discerning of the stability of these structures, we calculated the reaction energies for the most stable S-substituted 4L MoO<sub>3</sub> and O-substituted 6L MoS<sub>2</sub> nanostructures for different concentrations by using equations S3 and S4 as depicted in Fig 4. In this figure,  $\Delta E$  is the difference of

OK binding energy of the S-substituted 4L MoO<sub>3</sub> and O-substituted 6L MoS<sub>2</sub> systems with respect to DFT binding energies of H<sub>2</sub>S and H<sub>2</sub>O as reactants/products:

$$\Delta E = E_b(4L MoO_{3-x}S_x) - E_b(4L MoO_3) + xE_b(H_2O) - xE_b(H_2S) \quad (7)$$

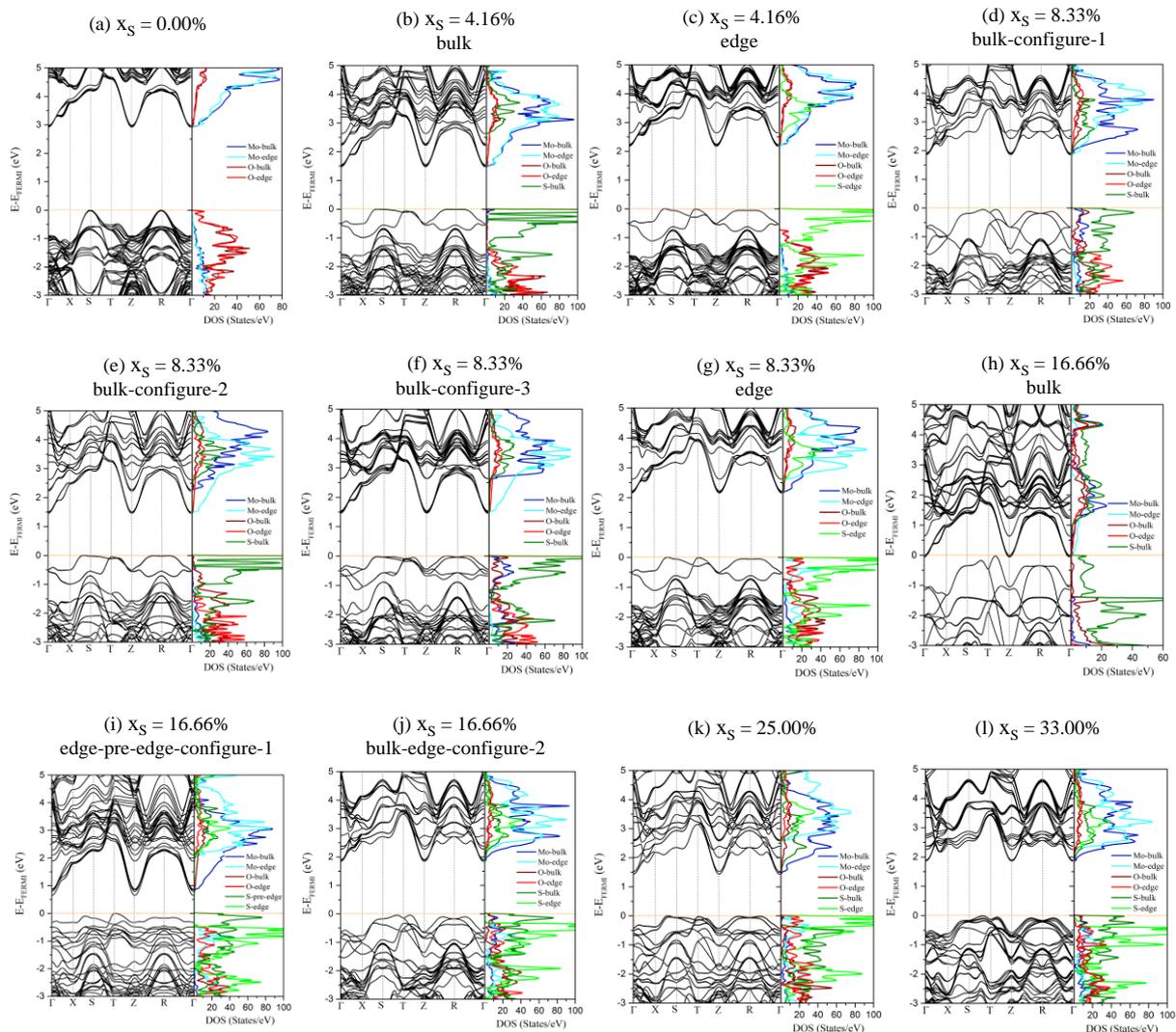
$\Delta G$  is the difference of binding energy of the S-substituted 4L MoO<sub>3</sub> and O-substituted 6L MoS<sub>2</sub> systems with respect to experimental free energies (enthalpy and entropy) of H<sub>2</sub>S and H<sub>2</sub>O given by NIST thermodynamic database:

$$\Delta G = E_b(4L MoO_{3-x}S_x) - E_b(4L MoO_3) + xG_b(H_2O) - xG_b(H_2S) \quad (8)$$

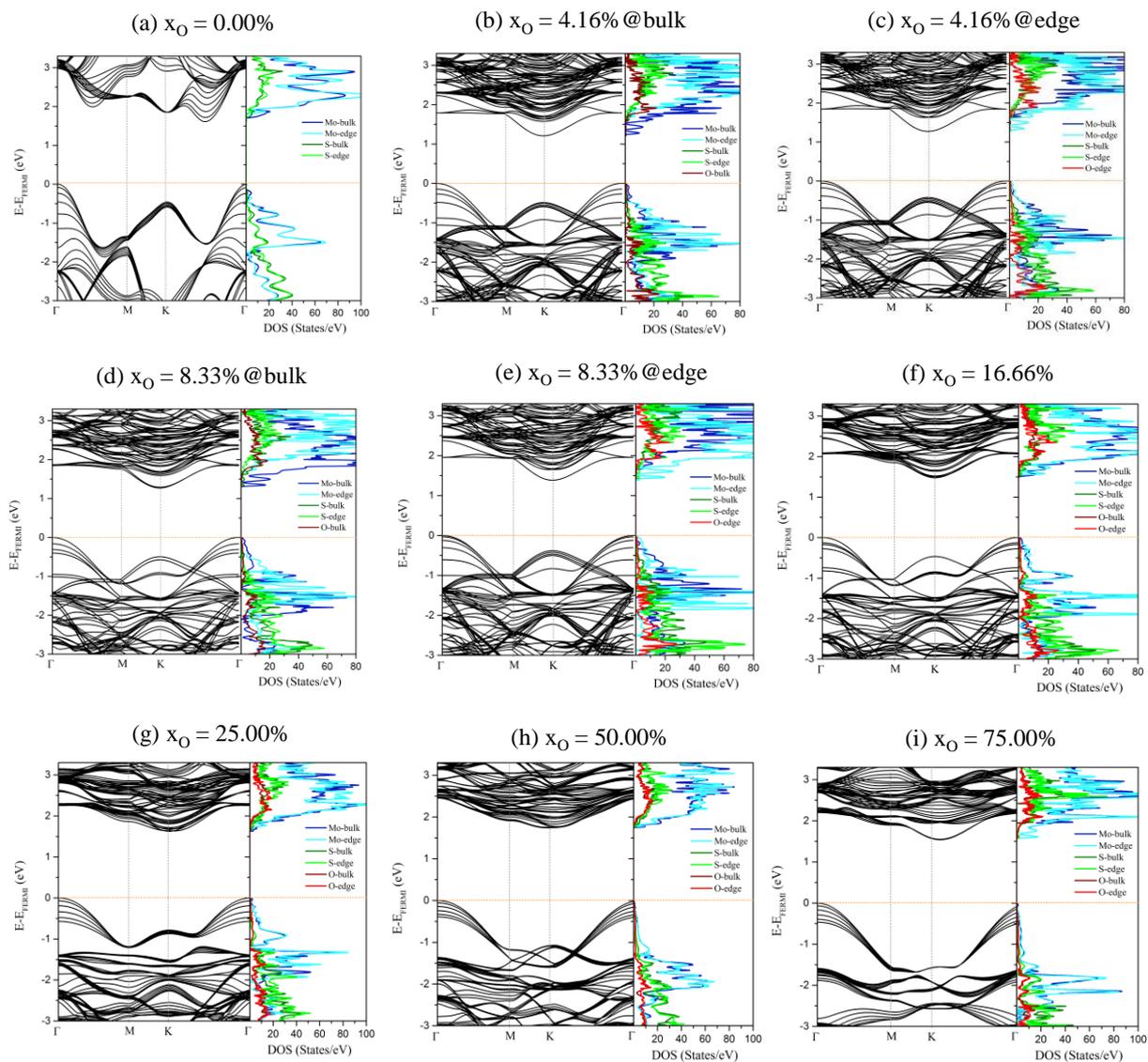


**Figure S6. Thermodynamic phase stability of the O-substituted 6L MoS<sub>2</sub> (a) structures for different S- and O-concentrations with respect to pristine structures considering the H<sub>2</sub>S/H<sub>2</sub>O reservoir. The dashed and dotted lines denote the results for impurity-substituted only in the edge and bulk of layered systems, respectively. (b) The calculated reaction energy for the most stable S-substituted 4L MoO<sub>3</sub> and O-substituted 6L MoS<sub>2</sub> structures for different concentrations.**

## S2.3 Electronic structure



**Figure S7.** Band structure and PDOS of the most stable S-substituted 4L MoO<sub>3</sub> structures for different concentrations calculated using HSE06. The Fermi level is set to zero. The related structures are presented in Figure S4.



**Figure S8.** Band structure and PDOS of the most stable O-substituted 6L MoS<sub>2</sub> structures for different concentrations calculated using HSE06. The Fermi level is set to zero. The related structures are presented in Figure S5.

## References

- 1 J. Even, L. Pedesseau and M. Kepenekian, Electronic surface states and dielectric self-energy profiles in colloidal nanoscale platelets of CdSe, *Phys. Chem. Chem. Phys.*, 2014, **16**, 25182–25190.
- 2 F. Giustino, P. Umari and A. Pasquarello, Dielectric Discontinuity at Interfaces in the Atomic-Scale Limit: Permittivity of Ultrathin Oxide Films on Silicon, *Phys. Rev. Lett.*, 2003, **91**, 267601.